## FNAL 3-year Single-Cell SRF Cavity Program

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### Introduction

This document describes a program to conduct single-cell SRF cavity R&D at Fermilab. The timeframe for this program is the 3-year period starting mid-FY2009 (3/1/09) through mid-FY2012 (ending 2/29/12). The program is intended to serve several objectives:

- 1. Carry forward the single-cell S0 program for the Americas Region under the ILC GDE and transform it into a program with a long horizon. This objective seeks improvement in the baseline cavity process through statistical observations and processing trials. The results of R&D can be readily implemented into design efforts for Project X, ILC, and other TESLA-type SRF cavity applications.
- 2. Initiate a coordinated program to address generic topics for SRF, in particular the development of an understanding of performance limits on the basis of materials and processing. This objective seeks *transformational* improvement through *basic materials science*, which could have tremendous impact on SRF cavity performance, yield, and cost, but could also necessitate cavity designs or processes that deviate largely from existing baselines.
- 3. Integrate *regional* expertise near Fermilab to produce a complete and effective world class singlecell research effort. This includes our partners at Cabot, Able, ANL, MSU, FSU, UC, NWU, IIT, and others.

Single-cell cavity programs have always been an integral part of SRF projects. Most performance records are associated with single-cell cavities, and processing breakthroughs have been pioneered first on single-cell cavities. The relatively low cost of single-cell cavities allows them to serve as the pivotal link between basic materials studies, which often requires destructive characterization, and actual behavior relevant to present technology, which involves 9-cell cavities in cryomodules. The relative ease of fabrication has been vital for the qualification of vendors. The smaller size of single-cell cavities means that tools and facilities can be qualified while still minimizing quantities of acid, liquid helium, etc.

The work plan will be partly driven by priorities set by TTC, ILC-GDE, and other SRF programs. Close communication with these programs will be essential to assure appropriate overlap and prevent unnecessary duplication. In addition, much work will be driven by scientific curiosity and the ability to leverage Fermilab's personnel and unique capabilities. These include the recent installation of an optical inspection system and its planned automation, a new temperature-mapping (Tmap) system, a custom designed and built tumbling machine, the availability of a class IV laser for spot re-melting, the development of coupon electropolishing and process witness capabilities, and the anticipated start of a processing apparatus solely dedicated to single-cell work. The work plan will further include strong interactions with university research groups, in particular the research consortia recently proposed to DOE-HEP (ANL / UC / IIT / FSU / NW and FNAL / UC / FSU / IIT / NW).

The work plan will be modified as necessary based on results obtained and new information. A central source of feedback will be reporting to TTC and ILC-GDE projects. In addition, Fermilab plans to continue hosting an annual SRF Materials Workshop as well as be a central participant in international SRF workshops and other superconductivity and accelerator conferences (ASC, PAC, etc). Reporting of results and feedback from peers at these venues will further serve to update the work plan.

Depending on the labor and resources available to the program, some or all of the milestones below could be met by FY2012. This includes achievements by collaborators enabled by this program.

- Tumbling and chemical-mechanical polishing recipes
- Safer and more environmentally benign chemical processing, rinsing, and degreasing routes
- Improved material specifications
- Pit-free welded cavities
- EP processes tuned to in-line fluorine monitors, oxidation kinetics, and material texture
- Remediation strategies for various performance limitations
- Feasibility of niobium-on-copper cavities by new routes
- Hydroformed single-cell cavities

## Scientific Approach

This research will be carried out primarily by the SRF Materials Group in Technical Division. A significant major role will be played by the A0 vertical test stand in Accelerator Division, with its personnel. As discussed later, the program assumes that the A0 VTS will become entirely dedicated to single-cell work, and that a vigorous development of support continues, such as continued development of Tmap systems. Also, some work will be carried out using the FNAL/ANL processing facility and the vertical test facility in IB1, after coordination with 9-cell processing and testing. The ANL and IB1 work is anticipated to occur at a 20% level.

Work areas and anticipated experiments fall into 6 categories as detailed below. Where appropriate, the scientific issues being addressed are stated. The baseline cavity processing sequence, testing sequence, diagnosis sequence, and performance benchmarks are attached as Appendix A. As stated there, a "qualified" single-cavity shall exceed 30 MV/m in vertical test at 2 K.

- 1. Qualify new vendors of SRF cavities.
  - **PAVAC**: Anticipated purchase of ~6 cavities late FY09 to early FY10.
  - **HC Starck sheets:** Fabricate 2-6 cavities using sheets from this new vendor. The manufacturer is to be determined.
- 2. Use proof-of-concept experiments to test process improvements.
  - **Tumbling**: Develop and apply a tumbling regimen to ~2 qualified cavities and ~2 unqualified cavities, then (a) compare results for tumbling to baseline EP process, (b) compare whether tumbling improves or degrades process. The actual process may be an integration of the baseline with tumbling, e.g. tumble for 100 µm material removal followed by 20 µm EP. Then extend method to new or unqualified cavities. *Issue: Does tumbling provide comparable or better performance with reduced reliance on hydrofluoric acid?*
  - High fluorine-concentration processing (FNAL + JLab): (a.k.a. "flash" processing): Compare performance for ~4 cavities processed under EP conditions that use fresh acid, or under other procedures to maintain a high fluorine gradient, to results for baseline processing. This includes developing a method to assess fluorine gradient during the EP process (presently a Raman spectrometer is sought for this purpose, as discussed later). *Issues: Are the benefits of "flash" processing compelling enough to offset increased complexity and acid use? Can we understand the mechanism why "flash" processing works?*
  - ECS validation: Compare performance for ~2 cavities that have been fabricated from sheets with known eddy-current scan defects and have been given a baseline process to assess whether the ECS control is useful. *Issue: The ECS defect cavities have been completed. The impact of defects on cavity performance is not known but is suspected to be bad.*

• Large grain (Niowave): Contract with Niowave / MSU to produce 2-3 cavities (1.3 GHz) from large ingot to validate formability, weldability, and processing claims. Rinse, assemble and test cavities to evaluate performance. *Issues: Our direct interaction should give us better grasp of potential cost issues as well as a better understanding of their production claims.* 

# **3.** Supply reference cavities for qualification of tools, procedures, processes, test stands, equipment, and so on.

- **ANL facility**: Processing to qualify the ANL facility is underway at the time of drafting this program. It will be assumed that the facility will be fully qualified when this is implemented.
- A0 VTS: Qualify this test facility using cavities with known low, medium, and high gradient.
- ICPA: ICPA operation is expected mid-FY2010. Repeat ~6 EP processing cycles on previously qualified cavity(ies) to demonstrate repeatability. Attain qualifying gradient ~3 consecutive times.
- **IB4 oven:** Qualify planned upgrade (FY2010 or later) to IB4 high-temperature bake oven to verify that gradient can be maintained in ~3 previously measured cavities.
- **High-resolution Tmap system (FNAL + JLab + Cornell)**: Provide cavities with known hot spots to qualify Tmap system (Muckerjee) and facilitate development of new systems (FY2010 and beyond) with JLab and Cornell (second sound). Explore whether high-resolution mapping combined with cavity modeling can be used to triangulate the location of field emitters.

# 4. (a) Supply benchmark cavities to serve as a baseline for subsequent experiments done by collaborators. (b) Also, accommodate process / test requests from collaborators.

- ALD cap and bake (ANL and JLab): Provide 1-2 cavities (1.3 GHz) after they have been given a baseline process and have passed a qualifying performance test. If requested, perform high-temperature or low-temperature vacuum baking. Then, perform rinsing and vertical testing. *Issues: Capping with aluminum oxide prevents oxygen from re-attacking the niobium surface. Baking decomposes niobium oxides and drives the oxygen down deep into the niobium bulk. Do these steps improve both Q and the quench field by removing "pollution" and possible contact with magnetic scattering sites?*
- ALD multilayer on niobium (ANL): Provide 1-2 cavities (either 1.3 or 3.9 GHz) after they have been given a baseline process and have passed a qualifying performance test. Then, perform rinsing and vertical testing after multilayers have been grown. The first step is a "niobium on niobium" cavity, upon which subsequent layers will be grown. *Issues: This is an explicit test of Alex Gurevich's theory that the limits of niobium bulk can be surpassed by multilayer geometries. Note: multilayer deposition requires development of a plasma-aided process at ANL, to be developed FY2010.*
- ALD niobium on copper (ANL + India + UES): Provide 2-3 copper cavities, which have been fabricated and qualified through India collaboration, to ANL for coating with niobium. As an alternative, or in addition, provide cavities to a new vendor (UES, Inc.) for coating via chemical vapor deposition. Then receive coated cavities, rinse, and assess performance with vertical test. Possibly re-process cavities with ICPA. *Issues: plasma-enhanced atomic layer deposition (PE-ALD) promises to be a very clean niobium deposition route, similar to chemical vapor deposition. Is this so?*
- **MgB<sub>2</sub> (Penn State):** Provide 1 cavity (3.9 GHz) with special end tubes to accommodate PSU's chemical vapor deposition system. Receive back a MgB<sub>2</sub> coated cavity. Possibly rinse with alcohol or CO<sub>2</sub>; this will not be water rinsed because water attacks MgB<sub>2</sub>. Vertical test to assess gradient and residual resistance at 2 K and 4.2 K. Possibly this experiment could be repeated. *Issue: Is MgB<sub>2</sub> a viable SRF material due to its much higher critical temperature of 39 K?*

- **EP** (**ABLE**): Provide ~6 qualified cavities to evaluate industrial electropolishing at ABLE Electropolishing. This consists both of 1.3 and 3.9 GHz cavities. *Issues: Can an industrial vendor provide sufficient quality, or does EP always have to be a processing activity that is coordinated with a lab? Will ABLE repeat solving vertical EP issues already solved by Cornell?*
- Chemical-mechanical polishing (CMP Cabot and Northeastern): Provide ~3 qualified cavities to Cabot to see if their proprietary slurries can achieve superior surface finishes without need for HF. Provide rinse and VTS for these cavities. Then, implement their slurries together with tumbling studies at FNAL on another ~3 cavities (FY 2010-2011). Also, accept ~3 cavities from Northeastern, who plan to apply CMP to sheets and half-cells *prior to welding* at AES, for possible process, test and analysis. *Issues: Is a nanometer RMS roughness achievable? Is non-HF processing viable?*
- **Rx and Rv half cells (FNAL and Black Labs and vendor TBD):** At Fermilab, revisit experiments to recrystallized (Rx) or recover (Rv) deep-drawn half cells prior to welding. Include coupons in the study. Fabricate 2 to 3 cavities and assess shrinkage, mechanical property sacrifices, possible changes to compromise, etc. Then, assess RRR and chemistry near welds by cutting apart one single-cell (3.9). Process the others using a baseline followed by rinse and test. Also, supply niobium sheet to Black Labs and another vendor for half cell processing and then pre-weld heat treatment. Then provide baseline processes and test welded cavities (2 to 4 in total). *Issues: Weld pitting may arise from dislocation clusters or interstitial atom clusters. Does pre-conditioning the material to alleviate the formation of such clusters reduce the tendency for pitting?*
- Textured sheets and single crystals (FNAL + MSU, JLab + Black Labs): Complete fabrication of single-crystal cavities at FNAL (two 3.9 GHz cavities). *Issues: Besides advantages for etching and smoothness, are there advantages for avoiding weld pits? Or, will dislocation pitting show up?* Also, conduct two experiments in parallel with textured sheet (~3 to 5 cavities each team, FY2010-2012): working with material vendors (Starck, Wah Chang), obtain niobium sheet with different crystallographic textures. Verify textures at MSU and Black Labs prior to, and after, deep-drawing. Weld half cells, analyze rotations of grains post-weld. Process per baseline, rinse, assemble, test. *Issues: These cavities should expose whether orientation aff*
- Hydroformed cavities (Ohio State, Texas A&M, MSU, Black Labs): Complete fabrication of 3.9 GHz hydroformed copper and niobium cavities at MSU, then process and test. Consider option for scaling up the MSU program to 1.3 GHz cavities at \$200k cost. Also, consider single-crystal cavities if \$300k funds for single-crystal tube refining (Nevada-Reno) becomes available. An additional benefit of the MSU program is the installation of a bulge test there during FY2010. Also, TAMU have demonstrated the grain refining of the weld zone of a seamed niobium tube. If funds are available, hydroform additional ~2 cavities at MSU using TAMU-refined tubes. Also, anticipate coordination of raw materials studies and provide cavity rinsing, assembly and testing to Black Labs for 2 to 3 three-cell cavities (or extract single cells from these 3-cell cavities), as part of SBIR work using the DESY facility (expected late FY2009 thru FY2011). Finally, Ohio State is fabricating extrusionbonded niobium-copper tubes under SBIR work. This work should be completed during mid to late FY2010 and these tubes should then be sent to MSU or to another institution (e.g. DESY, via Black Labs) for hydroforming. Issues: These experiments should help us understand better the wide range of raw materials issues, formability issues, and OA issues (e.g. bulge test) beyond the initial scope of the pioneering DESY work. In addition, feasibility of this process, in particular the raw materials supply chain, could be demonstrated.

#### 5. Test new cavity ideas:

- **In-situ remediation**: Complete several tests of laser re-melting using known pits in ~3 cavities. Reprocess cavities, either EP + Ultrasonic + HPR or just Ultrasonic + HPR. Assess feasibility of this process. Then (FY2011), consider mounting a reprocessing laser and mirror and gas purge in-line with optical inspection system for search-and-destroy remediation tool. *Issue: Using the laser may be more tractable and elegant than either small-pad grinding (Kyoto) or e-beam re-melting (JLab).*
- **Plasma post-processing:** Complete further tests to understand the viability of cavity post-processing once assembly is complete. This will likely be the summer intern work of a student.
- "Quench" cavity: Fabricate 1 cavity with altered shape that reduces the ratio of Eacc to B. In this case, field emitters are suppressed and sources of quenching are amplified. Re-evaluate the usefulness of this task after initial demonstration (FY2010).
- **Polyhedral cavity:** Working with Texas A&M, fabricate and test a longitudinal seam cavity as a demonstration of concept. If TAMU gain funding, it may be possible to extend this to a real cavity process and test.

#### 6. Develop characterization tools

- High-resolution temperature mapping: A robust T-mapping effort in parallel with the single cavity program is essential. One Tmap system is urgently needed for the A0 VTS, so this will be a high priority for the single-cell program. Two to three cavities will be made available for continual development and refining of temperature mapping systems. One of these cavities should have a known hot-spot arrangement and therefore will serve as a calibration for new Tmap systems. In particular, diode thermometry has the capability to increase the number of sensors placed on a cavity. Thereby, the amount of information we can gain increases to the point where it may become possible to triangulate on field emitters or assess Kapitza resistance at the outside of a cavity.
- **Optical inspection standards**: Cavities with calibrated pits, hand-made defects, positioning grids, and other features are needed for standards and calibrations for the optical inspection systems. This will require 2 to 3 non-qualified cavities.

## Work Plan

The metric of planned work is the number of expected cavity EP processes and test cycles. The work plan assumes 100% use of ICPA and up to 20% use of ANL as primary processing facilities. The work plan also assumes 100% use of the A0 vertical test stand and up to 20% use of the IB1 vertical test stand. The work plan assumes no use of facilities at JLab or Cornell; however, these facilities will be relied upon to provide additional resources to alleviate schedule delays.

At present, the ANL facility can handle 4 cavity processes per month<sup>\*</sup> with current manpower (Wu and Bice), or 48 processes per year. Adding a second work team (Scott Gerbick and Wade Muranyi) could increase this capability to 2 cavity processes per week or at maximum 100 processes per year. However, it should be stressed that the ANL facility is a *processing* facility, especially in the sense that once the processing parameters are established they should not be varied to maintain quality. That is, the ANL facility can *only* serve the single-cell tasks of providing benchmark cavity processing. Given pending cavity orders, and assuming that similar cavity purchases in out years will continue to drive the ANL

<sup>&</sup>lt;sup>\*</sup> Mike Kelly (ANL) estimates 4 processes per month, not 3 per 2 weeks.

schedule, approximately 40 processes at ANL are tied up by 9-cell work. The remaining ~8 processes (given present manpower) will be available to serve benchmark single-cell functions.

ICPA is expected to become operational in mid FY2010. The purpose of this facility is an *R&D* facility, providing the means to vary processing intelligently as well as handle non-standard cavity processing situations. Baseline processing can also be accomplished. It is expected that a 2-man team will be required to operate this apparatus, and staff is already here for that purpose (Thompson, Schuessler). The initial scope for this apparatus is 1 single-cell cavity process per week, or a maximum of 50 processes per year. The full capacity is intended to be 100 processes per year.

The vertical test stand (VTS) at A0 has entered the operational readiness clearance phase and should be ready for cavity testing at the start of this program. For purposes of scheduling, a 50% capacity (i.e. 25 tests) is assumed for the first year of operations at A0. Tests will be led by N. Dharanaj, and we will rely upon A0 technicians for operation and cryogenics at the facility. The vertical test stand at IB1 will continue to provide testing services for this program as well.

		Work period			
Work Area	Data	FY09-FY10	FY10-FY11	FY11-FY12	Grand Total
1 - qualify vendors	Sum of Total EP			9	9
	Sum of # of test cycles			9	9
2 - proof-of-concept	Sum of Total EP	1:	2 1	2 3	27
	Sum of # of test cycles	14	4 1	2 3	29
3 - reference	Sum of Total EP	(	)	6	6
	Sum of # of test cycles		6	6	12
4a - benchmarks to collaborators	Sum of Total EP		2	2 0	4
	Sum of # of test cycles	1:	2	4 10	26
4b - collaborator process / test	Sum of Total EP		1	0 4	14
	Sum of # of test cycles		1	1 4	15
5 - new ideas	Sum of Total EP	1(	) 1	0	20
	Sum of # of test cycles	1	7 1	0	27
6 - characterization tools	Sum of Total EP	(	)		0
	Sum of # of test cycles	(	)		0
Total Sum of Total EP		24	4 4	9 7	80
Total Sum of # of test cycles		49	9 5	2 17	118

Figure 1. Breakdown of cavity EP and test processes.

The total number of planned cavity processes over the 3-year program is 80, and the total number of vertical tests is 118. A breakdown of each cavity task is shown in fig. 1, and a further item-by-item breakdown is presented in Appendix B. The present cavity inventory is attached in Appendix C. As shown in Appendix B, new cavities will be added to the inventory as part of the R&D that will be performed. The present inventory, along with the anticipated additions, is sufficient to sustain the program as planned. Under the assumptions above, the ANL facility could provide 24-30 processes over the course of the program, while ICPA could provide approximately 100 processes. Note that several cavities in the inventory have already been given qualifying processes, so the oversubscription of FY09-FY10 EP processes is offset by the number of qualified cavities (~30) in the present inventory. Also, IB1 VTS could provide 24-30 vertical tests, and A0 VTS could provide approximately 125 vertical tests. Therefore, the work plan can be met with 10-20% reserve if the available facilities are fully utilized.

## Budget and development of resources

The following estimates are made, based on present information (discussed in more detail below):

- 1 cavity EP process per week at a cost of \$5k (acid, waste, maintenance) with a 2-man team at 0.5 FTE
- 1 rinse process per week (same week as cavity) at a cost of \$1k (hardware, water plant maintenance, not incl. clean room costs) using clean-room 1-man team at 0.5 FTE
- 1 test cycle per week at a cost of \$15k (helium, maintenance) using 3-man (operator, cryo tech, data analyst) team at 0.5 FTE

Development of resources will also be a key part of the program. Planned development includes:

- Purchase of a small quantity of niobium sheets, or use of excess niobium sheets, and using these sheets for custom cavity fabrication experiments
- Continued access to Sciaky for e-beam welding and training of Mike Foley's successor
- Support and maintenance of ICPA, with its clean room and HPR. (Note, support of A0 clean room with HPR is NOT considered).
- Tumbling, with tooling upgrade capable of chemical-mechanical polish
- Development of a Tmap system for A0
- Purchase of an additional optical inspection system and development of automation
- Upgrades to class IV laser to permit defect re-melting (mirrors, lenses)
- 120 °C oven retrofit at MDTL for low-T bake
- Purchase of new or rebuild of existing single-cell 1100 °C oven
- Seeding and support for university work

Cost item	Rate / Notes	FY09-FY10	FY10-FY11	FY11-FY12
Processing and testing				
EP + HPR costs	6000	144000	294000	42000
IB1 VTS	15000	120000	120000	120000
A0 VTS	8000	328000	352000	72000
Fixed costs				
IB4 clean room	18000	18000	18000	18000
A0 clean room	0	0	0	0
UHP water plant - IB4	10000	10000	10000	10000
UHP water plant - A0	0	0	0	0
ICPA (maint, clothes, etc)	8000	8000	8000	8000
ICPA completion	(under TD)			
Resource development				
A0 Tmap		50000		
Raman / FTIR (F- ion monitor)			175000	
Custom fabrication (2@8000)		16000	16000	16000
Tumbling upgrade for CMP				50000
New 1100 C oven			250000	
MDTL 120 C bake		15000		
Optical inspection standard		10000		
Optical inspection automation			40000	

Additional optical system				300000
Laser modifications for re-melting		10000		
Field emission monitoring @ A0		5000	5000	5000
Variable input couplers @ A0		10000		
University programs				
MSU - testing and forming	already seeded	50000	50000	
MSU - textured sheet	seed-deliver-fabricate	30000	50000	50000
TAMU - tube forming	seed-deliver-fabricate	30000	80000	
OhSU - tube forming	possible HEP grant			
UNR - zone refining	upgrade	300000	30000	
Northeastern	possible NSF grant			
Penn State	possible HEP grant			
Industry programs				
CMP at Cabot, xfer to tumbler			50000	
Black Labs - hydroforming	DESY machine here?		20000	40000
Black Labs - Rx sheet	custom fab above			
ABLE EP	CRADA - separate??			
Starck - purchase	purchase-deliver	25000		
PAVAC - purchase	purchase-deliver	90000		
Total M&S		1269000	1568000	731000
Total M&S		1269000	1568000	731000
Total M&S SWF	FTE	1269000	1568000	731000
Total M&S SWF Wu @ ANL	FTE 0.1	<b>1269000</b> 9000	<b>1568000</b> 9000	<b>731000</b> 9000
Total M&S SWF Wu @ ANL Bice @ ANL	FTE 0.1 0.1	<b>1269000</b> 9000 6000	<b>1568000</b> 9000 6000	<b>731000</b> 9000 6000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA	FTE 0.1 0.1 0.5	1269000 9000 6000 30000	1568000 9000 6000 30000	<b>731000</b> 9000 6000 30000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA	FTE 0.1 0.1 0.5 0.5	1269000 9000 6000 30000 22500	1568000 9000 6000 30000 22500	731000 9000 6000 30000 22500
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA	FTE 0.1 0.1 0.5 0.5 0.5	1269000 9000 6000 30000 22500 22500	1568000 9000 6000 30000 22500 22500	731000 9000 6000 30000 22500 22500
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0	FTE 0.1 0.5 0.5 0.5 0.5	1269000 9000 6000 30000 22500 22500 45000	1568000 9000 6000 30000 22500 22500 45000	731000 9000 6000 30000 22500 22500 45000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5	1269000 9000 6000 30000 22500 22500 45000 30000	1568000 9000 6000 30000 22500 22500 45000 30000	731000 9000 6000 30000 22500 22500 45000 30000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5	1269000 9000 6000 30000 22500 22500 45000 30000 22500	1568000 9000 6000 30000 22500 22500 45000 30000 22500	731000 9000 6000 30000 22500 22500 45000 30000 22500
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge)	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge) Tracking and logging (ND or MG)	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge) Tracking and logging (ND or MG) Weld metallurgist (Postdoc)	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2 0.5	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge) Tracking and logging (ND or MG) Weld metallurgist (Postdoc) Laser specialist (Wu, Nicol)	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2 0.5 0.5	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge) Tracking and logging (ND or MG) Weld metallurgist (Postdoc) Laser specialist (Wu, Nicol) Cooper - Tumbling @FNAL	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2 0.5 0.5 0.5	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge) Tracking and logging (ND or MG) Weld metallurgist (Postdoc) Laser specialist (Wu, Nicol) Cooper - Tumbling @ FNAL TBD - tech Tumbling @ FNAL	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2 0.5 0.5 0.5 0.5	1269000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000 22500	1568000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 22500 4500 18000 22500	731000 9000 6000 30000 22500 22500 45000 30000 22500 11700 18000 22500 4500 18000 22500 4500 18000 22500
Total M&S SWF Wu @ ANL Bice @ ANL Thompson @ ICPA Dave Burk @ ICPA (TBD - clean rm) @ ICPA Dharanaj @ A0 (TBD - VTS operator) @ A0 (TBD - VTS cryo) @ A0 (Muckerjee) - Tmap development Inspection (Sergatskov or Ge) Tracking and logging (ND or MG) Weld metallurgist (Postdoc) Laser specialist (Wu, Nicol) Cooper - Tumbling @ FNAL TBD - tech Tumbling @ FNAL	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2 0.2 0.5 0.5 0.5	1269000 9000 6000 30000 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000 22500	1568000 9000 6000 30000 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000 22500 4500	731000 9000 6000 30000 22500 45000 30000 22500 11700 18000 18000 22500 4500 18000 22500 4500 18000 22500
Total M&S   SWF   Wu @ ANL   Bice @ ANL   Thompson @ ICPA   Dave Burk @ ICPA   (TBD - clean rm) @ ICPA   Dharanaj @ A0   (TBD - VTS operator) @ A0   (TBD - VTS cryo) @ A0   (Muckerjee) - Tmap development   Inspection (Sergatskov or Ge)   Tracking and logging (ND or MG)   Weld metallurgist (Postdoc)   Laser specialist (Wu, Nicol)   Cooper - Tumbling @ FNAL   TBD - tech Tumbling @ FNAL	FTE 0.1 0.1 0.5 0.5 0.5 0.5 0.5 0.5 3 mos @ 0.5 = 0.13 0.2 0.2 0.5 0.5 0.5 0.5 0.5 0.5 0.5 0.5	1269000 9000 6000 22500 22500 45000 30000 22500 11700 18000 22500 18000 22500 18000 22500 18000 22500 302700	1568000 9000 6000 22500 22500 45000 30000 22500 11700 18000 22500 4500 18000 22500 4500 18000 22500 302700	731000 9000 6000 30000 22500 45000 30000 22500 11700 18000 22500 4500 18000 22500 4500 18000 22500 302700

## Synergistic activities

The single-cell program will benefit greatly from programs in place within the SRF Materials Group and the proposed university collaborations to conduct basic materials science. The SRF Materials Group presently conducts studies in the following areas:

- Weld coupons of niobium in different metallurgical states;
- Coupon-scale EP, fully instrumented for reproducibility or for process control with intelligent variation of parameters;
- Witness EP coupons that are put in-line with standard 1-cell EP and processed identically
- Optical, 3-D optical, and electron microscopy;
- Metallurgical testing.

In addition, collaborations with university groups can provide:

- Surface-science studies, including x-ray photoelectron spectroscopy, Auger electron spectroscopy, Raman spectroscopy;
- Chemical-kinetic studies, including real-time oxidation structures from scanning tunneling microscopy and 3-D atomic profiling;
- Structure-property studies, including scanning laser confocal microscopy, scanning electron microscopy with element identification and orientation imaging, transmission electron microscopy with holography and electron energy-loss spectroscopy, point-contact tunnel-junction spectroscopy, and atomic force microscopy;
- RF studies, including point-RF probe and non-linear strip-line resonator studies.

Key interactions to support these synergistic activities have already been established:

- Michigan State: orientation-imaging microscopy, sheet texture analyses, metallurgical expertise, cryogenic and bulge testing, forming science, hydroforming, welding science
- Florida State: grain-by-grain electron microscopy, magneto-optical imaging, laser scanning confocal microscopy, focused ion-beam micromachining, superconducting property measurements
- IIT: superconducting tunnel-junction spectroscopy
- Maryland: point RF probe analyses
- Northwestern: 3D atom probe reconstruction, depth profiling of composition, FIB micromachining
- Chicago: molecular diffraction for dynamic surface imaging, in-situ XPS, scanning tunneling microscopy, surface chemical kinetics
- Nevada-Reno: Zone refining and single-crystal niobium tubes
- Texas A&M: textured niobium, fine-grain seamed tubes (cheap tubes)
- Able Electropolishing: Single-cell EP
- Black Labs: niobium texture control, hydroforming, flow-formed tubes
- Ohio State: Nb/Cu extrusion bonded tubes and bi-metal hydroforming
- VCU: Hydroforming modeling

## Appendix A – Baseline techniques and performance standards

Italic font denotes optional steps.

#### Baseline Single-Cell Processing Recipe

- 1. Incoming cavity quality control checks.
- 2. Optical inspection of as-received cavity.
- 3. Bulk electro-polishing of ~150 um.
- 4. Ultrasonic degreasing.
- 5. High-pressure rinsing.
- 6. Hydrogen degassing at 600-800 °C.
- 7. Optical inspection.
- 8. 20 µm electro-polishing.
- 9. Ultrasonic degreasing.
- 10. High-pressure rinsing.
- 11. Assembly and vacuum leak testing.
- 12. 120 °C bake.
- 13. Vertical test.

### **Standard Testing Recipe**

- 1. Hold at ~100 K during cool down to check for Q disease.
- 2. Q vs. T measurement during cool down.
- 3. Q vs. E measurement. RF process as needed.
- 4. Final Q vs. E measurement.

Notes:

All Q vs. E measurements to include radiation data logging. Utilize temperature-mapping system if available.

### **Diagnostic Techniques**

- 1. Apply thermometry to determine location of limiting defect.
- 2. Perform optical inspection of limiting defect.
- 3. *Remediate defect by grinding, additional EP, additional degreasing, additional HPR, or other technique.*

#### **Performance Standards**

- 1. A cavity shall be considered as "qualified" if it attains 30 MV/m after being given the baseline process above.
- 2. A cavity may be considered as "qualified" if it attains 25 MV/m after an alternate process where BCP is substituted for EP in the baseline above and no final etching (steps 7-10) is done.

## Appendix B - Breakdown of individual single-cell experiments

			Duration	# existing 3.9 GHz	# existing 1.3 GHz	# new	# new		# Baseline			Other		# of test
Work Area	Single-cell experiment	Work period	(20d/mo)	cavities	cavities	3.9	1.3	Inventory assignment	EP	# Other EP	Total EP	cycles	Notes	cycles
1 - qualify vendors	Qualification of PAVAC cavities	FY10-FY11	120	0	0	0	6	NEW TE1PAV001-006	6	0	6			6
1 - qualify vendors	Qualification of HC Starck	FY10-FY11	60	0	0	0	3	NEW TE1STK001-003	3	0	3			3
2 - proof-of-concept	Tumbling experiments	FY09-FY10	200	3	4	0	0	3C1ROA001, 3C1FER004 and 005; 1.3 GHz cavities to be assigned	2	6	8	8	6 tumble + final EP, 2 baseline then test then tumble + final EP	10
2 - proof-of-concept	ECS defect	FY09-FY10	80	0	2	0	0	TE1ACC005 and 006	4	0	4			4
2 - proof-of-concept	High fluorine gradient	FY10-FY11	160	0	4	0	0	TE1AES001; 3 more required	4	4	8		2 baseline, 2 baseline + flash, 4 flash only - JLab?	8
2 - proof-of-concept	Weld pit studies	FY10-FY11	80	0	0	0	4	anticipated cavities made under atypical conditions	4	0	4			4
2 - proof-of-concept	Large grain	FY11-FY12	60	0	0	0	3	NEW Roark-Niowave from large grain	3	0	3			3
3 - reference	ANL Qualification	FY09-FY10	0	4	0	0	0	TE1ACC001-004	0	0	0		fully qualified at the start of this program	0
3 - reference	A0 VTS qualification	FY09-FY10	60	0	3	0	0	твр	0	0	0			3
3 - reference	Tmap system development	FY09-FY10	60	0	1	0	0	cavity with known pit, e.g. NR5	0	0	0	3	3 cycles of modification of Tmap system	3
3 - reference	ICPA certification	FY10-FY11	120	0	3	0	0	ANL qualification	6	0	6			6
4a - benchmarks to	ANI ALD can and bake	FY09-FY10	80	2	0	0	0	3C1R04003_3C1EER006	2	0	2			4
4a - benchmarks to	ANL ALD riobium on	11031110	00	۲	0	0	0	will not start until PEALD is in place:	2	0	۲		parameters loosely defined:	
collaborators	niobium	FY11-FY12	40	1	1	0	0	can use ACC or NR cavity	0	0	0	2	anticipate 2 BCP	2
4a - benchmarks to collaborators	ANL ALD multilayer	FY11-FY12	40	1	1	0	0	will not start until PEALD is in place; can use ACC or NR cavity	0	0	0	2	parameters loosely defined; anticipate 2 BCP	2
4a - benchmarks to	,		-											
collaborators	CVD niobium on copper	FY11-FY12	120	0	0	0	3	anticipated copper cavities from India	0	0	0	3	copper etching	6
4a - benchmarks to collaborators	Penn State - MgB2 cavity	FY09-FY10	40	1	0	0	0	3C1ROA005	0	0	0	1	BCP	2
4a - benchmarks to								3C1FER001 and 002, TE1ACC002;						
collaborators	ABLE EP	FY09-FY10	120	2	3	0	0	other cavity assignments pending	0	0	0	6	6 EP cycles at ABLE	6
4a - benchmarks to	CMP (Cabot)	EV10_EV11	80	0	2	0	0	$TE1AES005 \pm one covity TBD$	0	2	2	2	2 cycles at Capot possibly	1
4b - collaborator process		1110-1111		0	2	0	0	TETAE 3003 + one cavity TBD	0	2	2	2	Tonowed by 2 short Er	
/ test	CMP (Northeastern)	FY10-FY11	80	0	0	0	2	2 new cavities fab by AES	0	0	0	4	4 CMP cycles at Northeastern	4
4b - collaborator process	Px and Py half calls	EV10 EV11	120	0	0	2	2	Join with weld prep study; possible	4	2	6	٨	possible inspection and	1
4b - collaborator process	Ohio State Nb/Cu extruded	FTIU-FTII	120	0	0	2	2	NOA OF AES TOF 1.5 Weld	4	2	0	4		4
/ test	tube hydroformed cavity	FY11-FY12	40	0	0	1	1	SBIR	2	0	2			2
4b - collaborator process	MSU hydroformed niobium													
/ test	tube	FY10-FY11	20	0	0	1	0	FNAL funded	1	0	1			1
4b - collaborator process	Texas A&M ECAE seamed													
/ test	tube hydroformed	FY11-FY12	20	0	0	1	0	FNAL funded	1	0	1			1
40 - collaborator process	MSU + UNR Single-crystal	EV11-EV12	20	0	0	1	0	ENAL funded	1	0	1			1
4b - collaborator process		1 1 1 1 - 1 1 1 2	20	0	0	1	0		I	0	1			1
/ test	Black Labs - Hydroformed	FY10-FY11	60	0	0	0	3	SBIR	3	0	3		Using DESY tool	2
5 - new ideas	remediation (grinding, laser,	FY09-FY10	120	0	2	0	0	TE1AES004, NR-5, NR-6	2	4	6	6	followed by short EP	6
5 - new ideas	grain	FY09-FY10	160	0	0	4	0	3C1FER008 thru 011	4	0	4	4	BCP for crystal and large grain	8

													possible inspection and	
5 - new ideas	Textured sheet	FY10-FY11	160	0	0	0	4	vendors TBD	8	0	8		dissection cycles	8
								likely to combine with weld pit						
5 - new ideas	Quench cavity	FY10-FY11	40	0	0	0	1	"standard" idea to make new cavity	2	0	2			2
	Plasma, ion cluster							3C1FER003, 3C1FER007,						
5 - new ideas	cleaning, helium processing	FY09-FY10	60	3	0	0	0	3C1ROA004	0	0	0			3
	Optical inspection												Use laser to make controlled pit	
6 - characterization to	ools standards	FY09-FY10	0	0	2	0	0	TE1AES004?? NR-5??	0	0	0		and add calibration markings	0
	Standard for Tmap												Cavity with well-known quench	
6 - characterization to	pols development	FY09-FY10	0	0	1	0	0	TBD	0	0	0		site for calibrations	0
Total											80	45		118

#### APPENDIX C - PRESENT CAVITY INVENTORY

#### 3.9GHz Single Cell Summary 3C: 3rd harmonic single cell center cell

#### Last updated on 2/12/2009

					Delivery	Order
Number	Current location	Main purpose	Current Status	Notes	date	Date
3C1FER001	FNAL_IB3	Tumble+EP		C Cooper	~2006	
3C1FER002	ABLE	Tumble+EP	EP setup	C Cooper	~2006	
3C1FER003	ICB first floor	GCIB, Plasma	Waiting for RF components	G Wu	~2006	
3C1ROA001	Reeves's office	Tumble+EP		C Cooper	9/15/2007	
3C1ROA002	Reeves's office	BCP verification			9/15/2007	
3C1ROA003	Reeves's office	ALD	To be degreased, queued after 3C1ROA00	5	9/15/2007	
3C1ROA004	FNAL_ICB	helium processing	BCP 80 minutes done, early quench	around 12 MV/m quenched	9/15/2007	
3C1ROA005	FNAL/MDTL	MgB2	80 min BCP done, waiting for funding	G Wu Shorter beam pipe	9/15/2007	
3C1FER004	A0 cabinet	Tumble+EP		C Cooper	3/7/2008	
3C1FER005	A0 cabinet	Tumble+EP		C Cooper	3/7/2008	
3C1FER006	A0 cabinet	ALD, Tumble+EP		NbTi material ready 8/9/2007	3/7/2008	
3C1FER007	A0 cabinet	Plasma processing		Uses 9-cell flange with transision rings	3/7/2008	
3C1FER008	To be made at Fermilab	Large grain study		Blanks ready to scan on 8/15/2007		
3C1FER009	To be made at Fermilab	Large grain study				
3C1FER010	To be made at Fermilab	Single crystal study				
3C1FER011	To be made at Fermilab	Single crystal study		Blanks ready		

#### 1.3GHz Single Cell Summary TE: Tesla Endcell shape

					Delivery	Order		
Number	Current location	Main purpose	Current status	Notes	date	Date	Images	
TE1AES001	JLAB	Single cell EP	At Jlab, single cell EP setup	27.8 MV/m limited by Q-slope	8/31/2007	6/11/2007		
TE1AES002	Cornell Univ.	Q-slope	Medium field Q-slope	17 MV/m limited by FE	8/31/2007	6/11/2007		
TE1AES003	TRIUMF	TRIUMF commissioning		28 MV/m limited by Q-slope	8/31/2007	6/11/2007		
TE1AES004	FNAL IB1	Equator pit, quench at high	visual inspection done, HPR pit study	39.2 MV/m, limited by Quench	8/31/2007	6/11/2007	Inspection	Image by M. Ge
TE1AES005	ANL208	CMP studies, EP, ABLE	Seal surface scratches, repaired	26.7 MV/m limited by Q-slope	8/31/2007	6/11/2007	TE1AES005_imaging.htm	Image by A. Crawford
TE1AES006	Cornell Univ.	Q-slope	Medium field Q-slope	To be tested soon	8/31/2007	6/11/2007		
TE1ACC001	FNAL ICB	EP Optimization	inspected and To be EP at ANL		12/29/2008	3/26/2008	Inspection	Image by M. Ge
TE1ACC002	ANL208	EP Optimization	112 micron EP, RF test done	33 MV/m limited by FE and Qslope	12/29/2008	3/26/2008	Inspection	Image by M. Ge
TE1ACC003	FNAL ICB	EP Optimization	To be inspected and EP		12/29/2008	3/26/2008	-	
TE1ACC004	FNAL ICB	EP Optimization	To be inspected and EP		12/29/2008	3/26/2008		
TE1ACC005	FNAL ICB	Eddy current scanning	To be inspected and progressive EP		12/29/2008	3/26/2008		
TE1ACC006	FNAL ICB	Eddy current scanning	To be inspected and progressive EP		12/29/2008	3/26/2008		
<u>NR-1</u>	Cornell Univ.		in transit to Cornell	26.5 MV/m limited by FE, Quench	6/11/2008		Inspection	Image by M. Ge
<u>NR-2</u>	Cornell Univ.		VEP at Cornell	26 MV/m limited by Quench after VEP	6/11/2008		NR-2 imaging	Image by Z. Conway
<u>NR-3</u>	Cornell Univ.		More BCP done at Cornell	22.8 MV/m : new test result	6/11/2008		NR-3_imaging	Image by Z. Conway
<u>NR-4</u>	FNAL/A0	ABLE EP	Connected to vacuum pump	28.7 MV/m limited by Q-slope	6/11/2008		Pending	
<u>NR-5</u>	Cornell Univ.	E-beam weld on Pit	equator weld pit	24.7 MV/m limited by Quench	6/11/2008		Pending from Conway (Cornell)	
<u>NR-6</u>	Cornell Univ.	Laser re-melting	equator weld pit	26.8 MV/m limited by Quench	6/11/2008		NR-6_imaging	Image by Z. Conway
	NR single cell summary	report by Cornell on 11/12/	<u>2008</u>					

#### FNAL ANL facility cummulative RF test cycles

Many people contributed to various works listed here. If you want to quote the data here, please contact M. Champion or G. Wu to make sure proper credit will be given to those who did actual works.

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